



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2829  
Examiner: J. Hollington

In Re NEW PATENT APPLICATION Of:

Applicant: Mikio OHTAKI )  
Appln. No.: 09/904,663 )  
Filed: July 16, 2001 )  
For: SEMICONDUCTOR DEVICE )  
TEST METHOD )  
Atty Ref.: KAN 120D1 )

**INFORMATION  
DISCLOSURE  
STATEMENT**

October 18, 2002

Commissioner for Patents  
Washington, D.C. 20231

Sir:

This is an Information Disclosure Statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(c)(2), i.e., after a first Office Action on the merits but before Final Rejection and/or Notice of Allowance, along with the required fee of \$180, under 37 C.F.R. §1.17(p).

A Japanese Office Action dated July 11, 2002 for the corresponding Application cited the document JP 64001252. The publication is cited on the attached Form PTO-1449. Consideration of the document is respectfully requested.

Respectfully submitted,

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CUSTOMER NO. 23995

October 18, 2002  
Date

10/22/2002 AADDF01 00000018 09904663

01 FC:1806

180.00 DP

SMR:pjl

FEE ENCLOSED: \$180.  
Please charge any further  
fee to our Deposit Account  
No. 18-0002